UC 1129

U.S. UTILITY Patent Application

10015601 12/17/2001 34 17 2871 607 **APPLICANTS: Takahashi Nobuyuki; 365 2 **CONTINUING DATA VERIFIED: **FOREIGN APPLICATIONS VERIFIED: JAPAN JP2000-399444 12/27/2000	NUM FILING DATE CLASS	S SUBCLASS GAU	EXAMINER
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preign priority claimed ☐ yes ☐ no ATTORNEY DOCKET NO USC 119 conditions met ☐ yes ☐ no 01425-120	ority claimed	es 🖸 no	
TLE : Interback-type substrate processing device	nterback-type substrate processin	ng device	U.S.DEPT. OF COMM./PAT.3 TM-PTO-436L(Rev :

NOTICE FALL	OWANCE MAILED		CLAIMS ALLOWED				
		Assistant Examiner	Total Claims Pri		rint Claim for .G		
ISSUE FEE		pp.	DRAWING				
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		Primary Examiner		•	· · · · · · · · · · · · · · · · · · ·		
TERMINAL		· PREPARED FOR ISSUE	SUE Application Examiner .				
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